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PATENT APPLICATION  
*#3 05/20/03*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yoshitaka SASAKI et al.

Group Art Unit: 3729

Application No.: 09/650,690

Examiner: R. K. Chang

Filed: August 30, 2000

Docket No.: 100988.01

For: METHOD FOR MANUFACTURING THIN FILM MAGNETIC HEAD WITH  
IMPROVED PERFORMANCE

AMENDMENT

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

RECEIVED  
APR 29 2003  
TECHNOLOGY CENTER R3700

Sir:

In reply to the October 23, 2002 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE ABSTRACT:

Please replace the Abstract filed with the substitute Abstract attached hereto.

IN THE CLAIMS:

Please cancel claims 11-22 without prejudice to or disclaimer of the subject matter contained therein.

Please add new claims 23-33 as follows:

- 
- 23. (New) A method of manufacturing a thin film magnetic head comprising:
- forming a first magnetic layer having a pole portion on a base substrate;
  - forming a first insulating layer on the first magnetic layer;

*B2*